



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re New Patent Application of)
Nobuhiro JIWARI et al.)
Japanese Priority Application No. 11-319087) Attn: Applications
Japanese Priority Date: November 10, 1999) Branch
For: METHOD FOR FABRICATING)
SEMICONDUCTOR DEVICE)

INFORMATION DISCLOSURE STATEMENT

Honorable Assistant Commissioner for Patents


Washington, D.C. 20231

Sir:

In accordance with the provisions of 37 C.F.R. 1.56 and 37 C.F.R. 1.97-1.99, it is requested that the reference listed on the attached Form PTO-1449 be made of record in the above-identified application.

A copy of this reference is submitted herewith in accordance with 37 C.F.R. 1.98(a).

Respectfully submitted,



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Form PTO-1449
(Rev. 8-83)U.S. Department of Commerce
Patent and Trademark Office

Attorney Docket No. 0819-450

Serial No. Not Yet Assigned

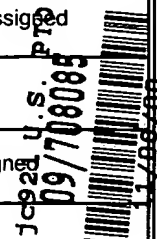
INFORMATION DISCLOSURE STATEMENT

(Use several sheets if necessary)

Applicant: Nobuhiro JIWARI et al.

Filing Date:

Group: Not Yet Assigned

**U.S. PATENT DOCUMENTS**

Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date (if appropriate)

FOREIGN PATENT DOCUMENTS

Document Number	Date	Country	Class	Subclass	Translation Yes No
10-199976	07/31/98	Japan			Abstract

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

Examiner

Date Considered

*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.